



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

ZHANG et al.

Serial No. 09/633,869

Filed: 08/07/2000

For: METHOD FOR LASER-PROCESSING

SEMICONDUCTOR DEVICE

)

)

) Group Art Unit: 2812

) Examiner: V. Simko

)

)

) Date: July 26, 2001

RECEIVED
JAN - 3 2002
TC 2800 MAIL ROOM

**SECOND REQUEST FOR ACKNOWLEDGMENT OF
INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents

Washington, D.C. 20231

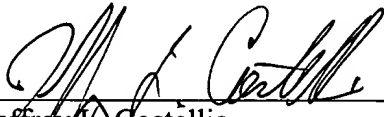
Sir:

Applicants acknowledge with the Official Action mailed November 30, 2001. Although the Official Action included a copy of an initialed Form PTO-1449 acknowledging the Information Disclosure Statements filed August 30, 2001 and October 5, 2001, we still did not receive the full initialed PTO-1449 of the Information Disclosure Statement filed August 7, 2000 as requested in our previous Request for Acknowledgment of Information Statement submitted July 26, 2001.

Therefore, it is respectfully requested that the Examiner evidence consideration of the all of the references cited in the IDS of August 7, 2000, by providing a copy of the completely initialed Form PTO-1449.

If a conference would be beneficial in expediting the prosecution of the instant application, the Examiner is invited to telephone the undersigned to arrange such a conference.

Respectfully submitted,



Jeffrey L. Costellia
Registration No. 35,483

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110
(703) 883-0370 (FAX)